

CPA/1765
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C12395 CIP

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#10
In re
8/30/01

In re Application of:

YOSHIHIKO FUKUMOTO

Application No.: 09/429,530

Filed: October 28, 1999

For: METHOD FOR FABRICATING
SEMICONDUCTOR DEVICE

Examiner: V. Perez Ramos

Group Art Unit: 1765

August 28, 2001

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AUG 30 2001
TC 1700

Commissioner for Patents
Washington, D.C. 20231

PETITION UNDER 37 C.F.R. § 1.136(a)

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated February 28, 2001, for three months from May 28, 2001, to August 28, 2001.

Submitted herewith is a check for \$890.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205. A duplicate copy of this petition is enclosed.

08/29/2001 CNGUYEN 00000046 09429530

01 FC:117

890.00 OP

Applicant's undersigned attorney may be reached in our Washington DC office by telephone at (202) 530-1010. All correspondence should continue to be directed to our New York office at the address given below.

Respectfully submitted,



Attorney for Applicant

Registration No. 32,533

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